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Revised
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PATENTS

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANTS: VON AMMON ET AL 9
SERIAL NO.: 09/813,240 EXAMINER: J. MONDT
FILED: MARCH 20, 2001 GROUP: 2826
TITLE: SEMICONDUCTOR WAFER MADE FROM SILICON AND
METHOD FOR PRODUCING THE SEMICONDUCTOR WAFERS

RESPONSE TO NONFINAL OFFICE ACTION

ATTN: BOX NON-FEE AMENDMENT
Assistant Commissioner of Patents
Washington, D.C. 20231

Dear Sir:

This is in response to the Nonfinal Office Action dated
June 26, 2002.

REMARKS

Reconsideration of this patent application is respectfully
requested in view of the following remarks.

The Patent Examiner has rejected all the claims 2 and 4 to 6
as being unpatentable under 35 U.S.C. 103 over the following
prior art references in various combinations thereof: namely
Tamatsuka et al (6,291,874) (newly cited) in view of *Kuhn-*
Kuhnenfeldt et al (4,330,361) (newly cited), and further in view
of *Tamatsuka et al* (6,224,668) (previously cited), or *Kim*